### **International Prosecution**

-Tips on how to prepare a global filing with considerations for China

Jimmy Chen jimmyc@cn.ibm.com

1 Copyright © IBM Corporation 2020

1



# **Agenda**

- China patent system
- Tips for preparation considering a Chinese filing
  - **≻**Specifications
  - **≻Claims**

Copyright © IBM Corporation 2020

#### **China Patent System**

Copyright © IBM Corporation 2020

2



# **China Patent System**

- First-to-file system
- Three types of patents
  - >Invention patents
  - >Utility model patents
  - **≻**Design patents
- Three ways of filing
  - **➢ Direct filing**
  - **▶** Paris convention filing
  - > PCT filing with China as designated country

Copyright © IBM Corporation 2020



# **China Patent System - Invention**

- Eligible subject matter
  - **≻**Technical requirements (problem means effects)
  - >Statutory exceptions
- Novelty
- Inventiveness (three-step method)
  - > Determining the closest prior art
  - > Determining the distinguishing tech features of the invention v. tech problem actually solved by the invention
  - ➤ Determining whether the claimed invention is obvious to a PSITA
- Usefulness

Copyright © IBM Corporation 2020

5



**Drafting Tips** 

Copyright © IBM Corporation 2020



Find the full text of this and thousands of other resources from leading experts in dozens of legal practice areas in the <u>UT Law CLE eLibrary (utcle.org/elibrary)</u>

Title search: International Prosecution

Also available as part of the eCourse 2020 Advanced Patent Law (Austin) eConference

First appeared as part of the conference materials for the 25<sup>th</sup> Annual Advanced Patent Law Institute session "International Prosecution"